

Docket No. F-7337

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2815****RECEIVED  
CENTRAL FAX CENTER****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****MAR 22 2004**

Applicant : Shigeki SAKAI, et al.  
Serial No. : 10/090,851  
Filed : March 4, 2002  
For : SEMICONDUCTOR NONVOLATILE STORAGE  
ELEMENT AND METHOD OF FABRICATING THE  
SAME  
Group Art Unit : 2815  
Examiner : Jesse A. Fenty  
Confirmation No. : 5906  
Customer No. : 000028107

**OFFICIAL****Certificate of Facsimile Transmission Under 37 CFR 1.8**

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Herbert F. Ruschmann  
(Name)

  
(Signature)

MAIL STOP NON-FEE AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

Sir:

F7337 am02 (PC 10) wpd

Docket No. F-7337

Ser. No. 10/090,851

In response to the final Office Action of December 23, 2003, entry of the present amendment effecting claim amendments to place the application into condition for allowance is respectfully requested. Please amend the above-identified patent application as follows: